

212706US-2S

"RESPONSE UNDER 37 CFR 1.116-  
EXPEDITED PROCEDURE EXAMINING  
GROUP 2814"

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#12/Draftsman

2/14/03

Hayes

IN RE APPLICATION OF: :  
Kazuhiro SHIMIZU, et al. : GROUP: 2814  
SERIAL NO.: 09/925,418 :  
FILED: August 10, 2001 : EXAMINER: Weiss, H.  
FOR: NON-VOLATILE :  
SEMICONDUCTOR MEMORY :  
DEVICE HAVING MEMORY :  
CELL ARRAY SUITABLE FOR :  
HIGH DENSITY AND HIGH :  
INTEGRATION :

RECEIVED  
JAN 29 2003  
TECHNOLOGY CENTER 2800

LETTER TO THE OFFICIAL DRAFTSMAN

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

Any corrections required by the Chief Draftsman or drawing amendments approved by the Examiner have been incorporated into the copies of the Formal Drawings submitted herewith. It is requested that the enclosed 11 sheets of Formal Drawings be entered to replace the drawings previously filed in this application.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

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